

Solution-Processed Light Induced Multilevel Non-volatile Wearable Memory Device Based on CsPb_2Br_5 Perovskite

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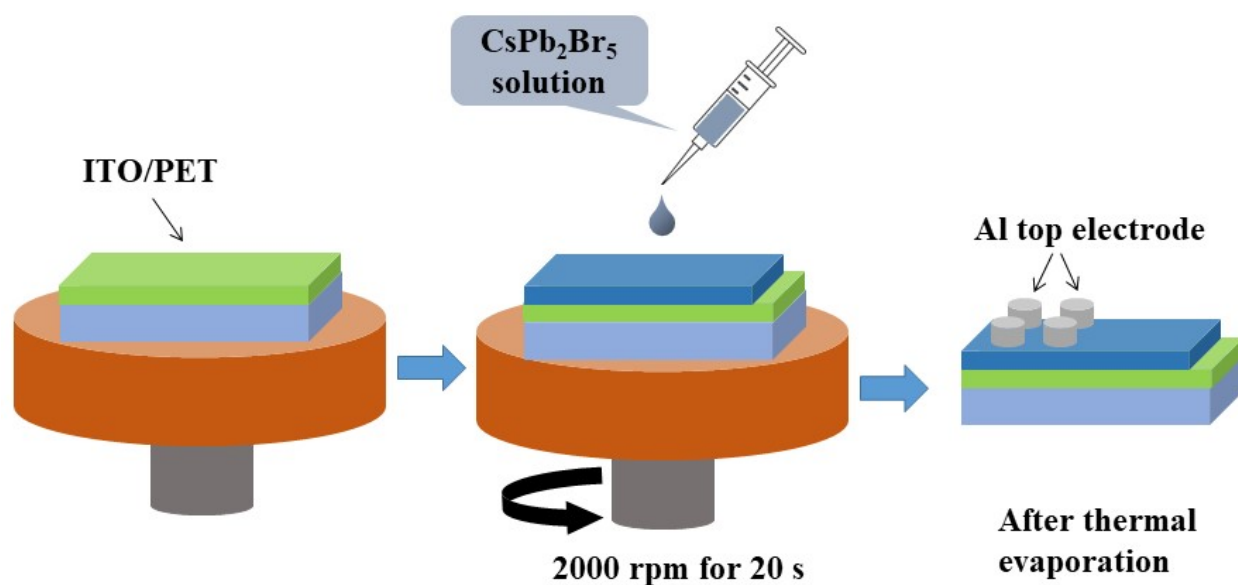


Figure S1: Schematic illustration of the device fabrication.

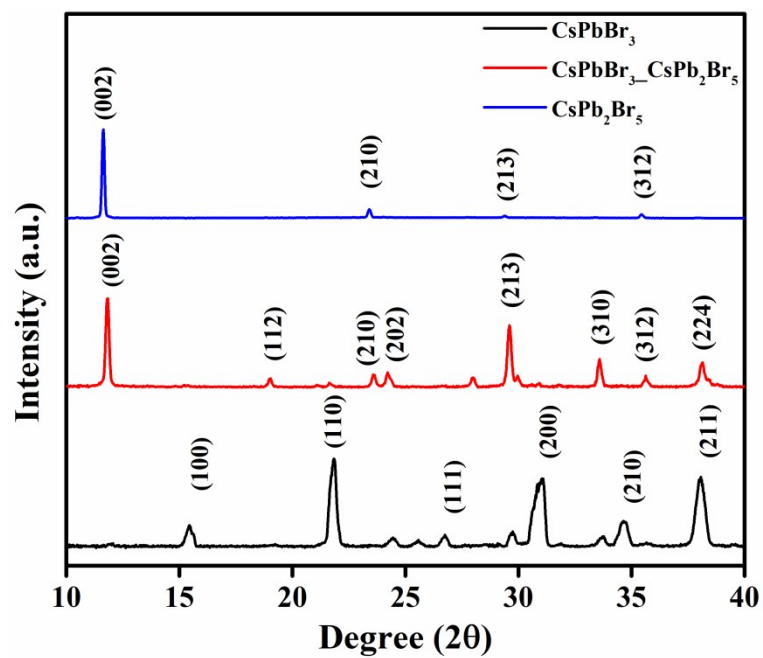


Figure S2: XRD profile of CsPb_2Br_5 is compared with pure CsPbBr_3 and $\text{CsPb}_2\text{Br}_5\text{-CsPbBr}_3$.

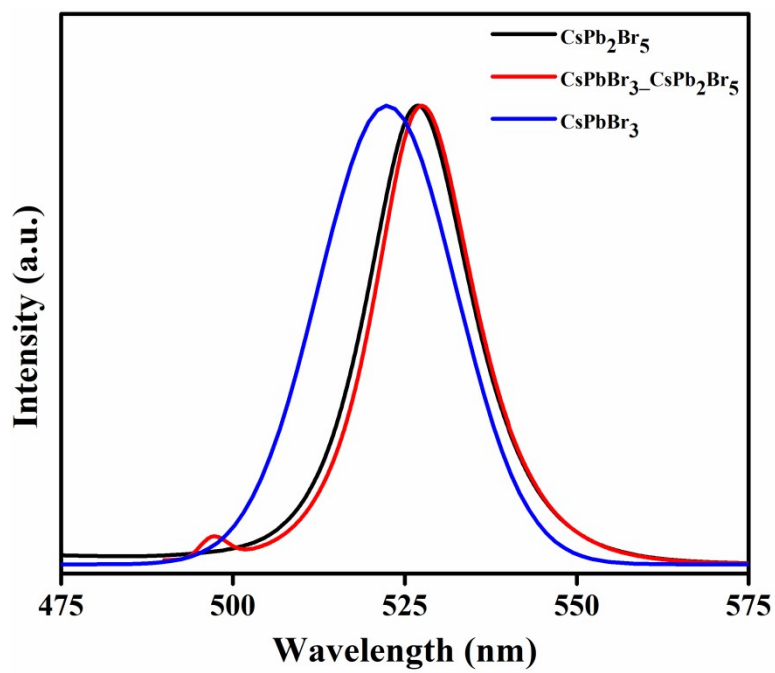


Figure S3: Photoluminescence analysis of CsPb_2Br_5 is compared with pure CsPbBr_3 and $\text{CsPb}_2\text{Br}_5\text{-CsPbBr}_3$.

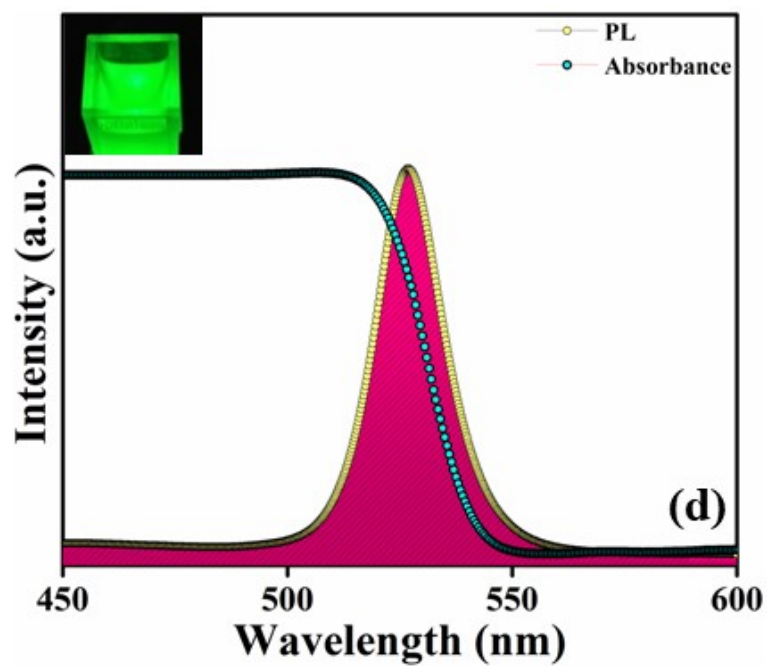


Figure S4: UV-vis absorbance and PL spectra of the CsPb_2Br_5 .

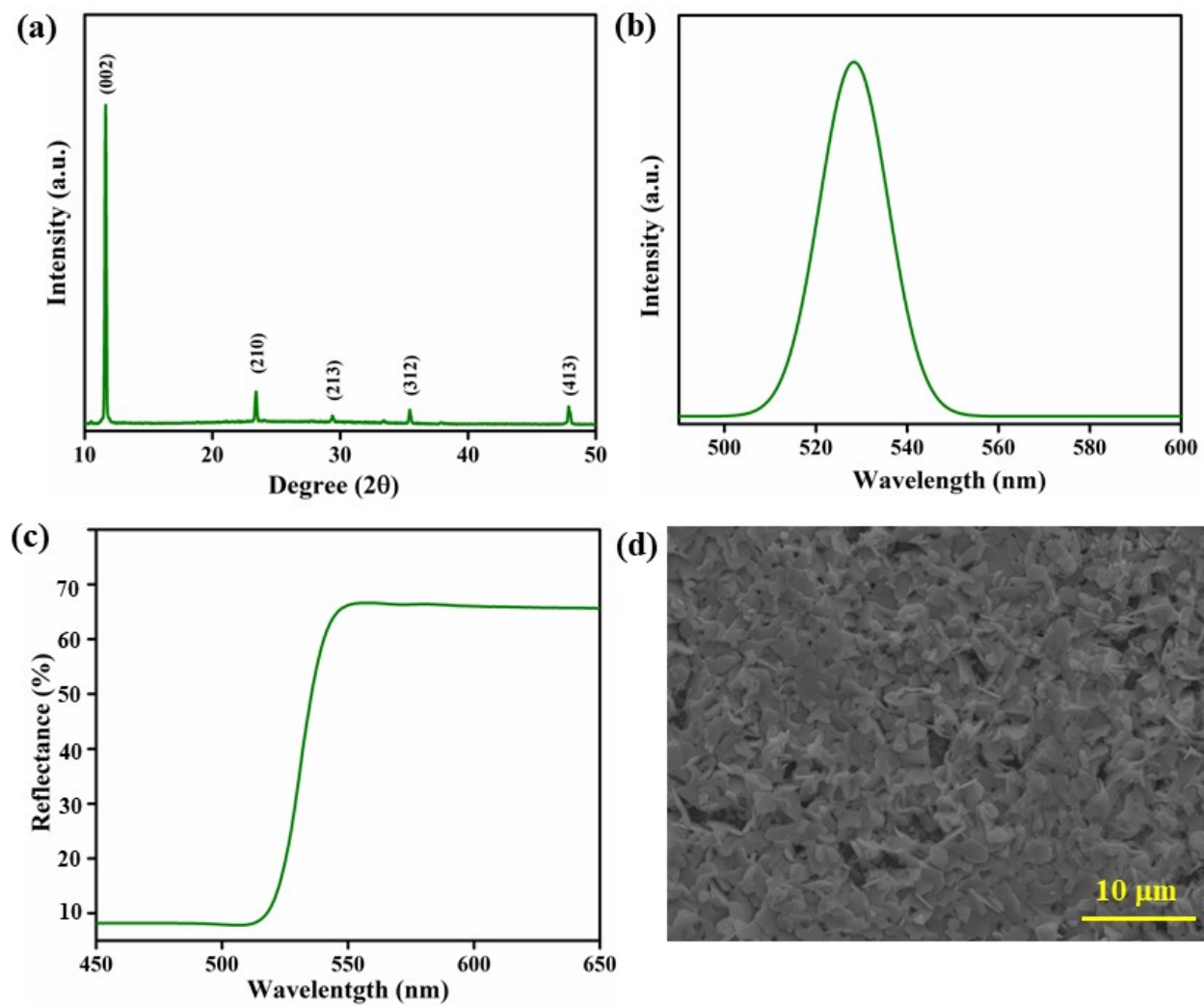


Figure S5: XRD, PL, UV-Vis and FESEM of the perovskite film.

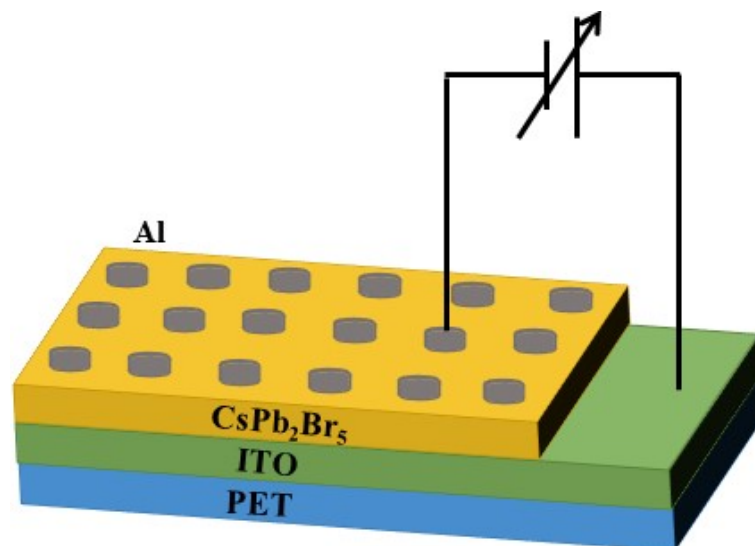


Figure S6: Schematic diagram of the designed memory device.

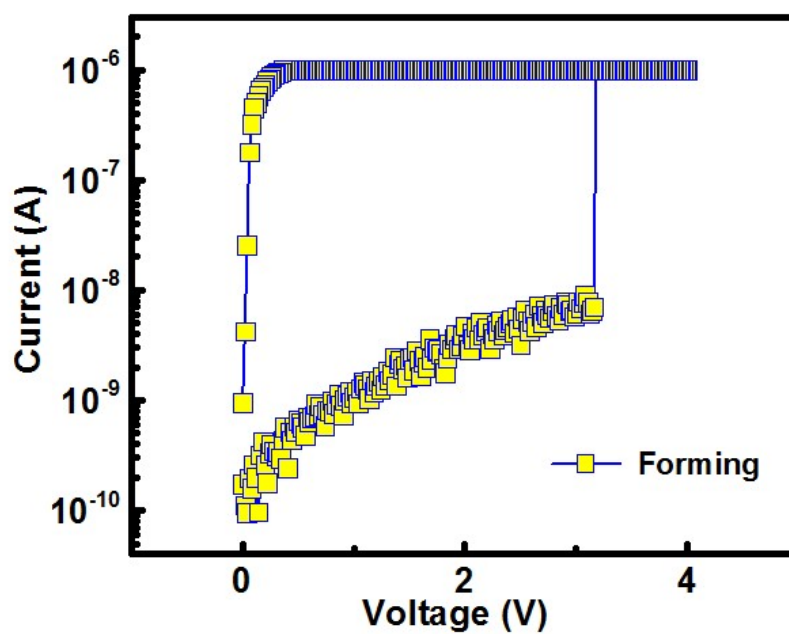


Figure S7: Forming process of the Al/CsPb₂Br₅/ITO device.

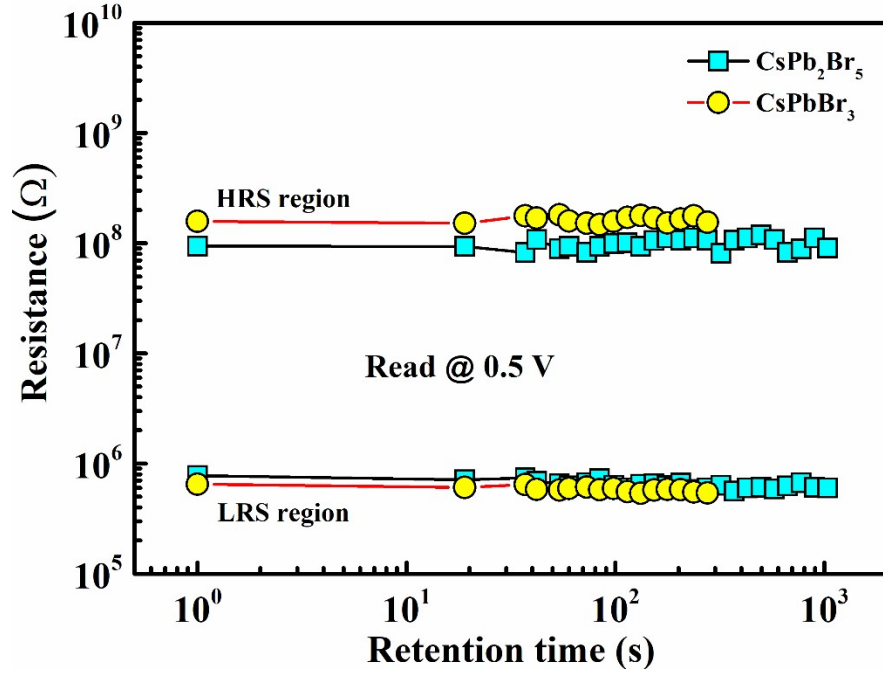


Figure S8: Performance comparison with CsPbBr_3

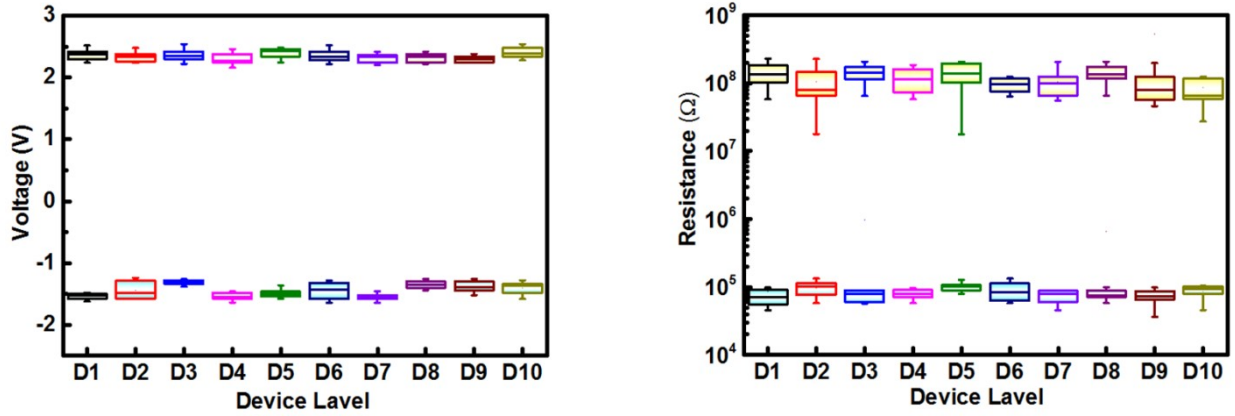


Figure S9: Statistical distribution of (a) the switching voltage (b) LRS and HRS for various Al/CsPb₂Br₅/ITO memory cells.

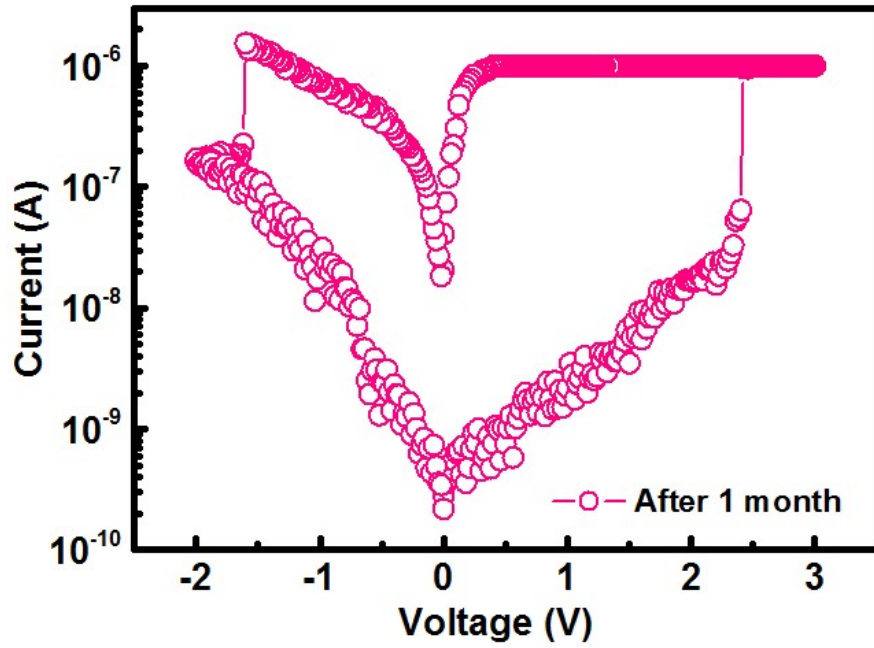


Figure S10: I-V curve of the Al/CsPb₂Br₅/ITO/PET device after 1 month.

Table S1: Comparison of perovskite-based resistive memory devices with the proposed device

Sl. No.	Material	Device Structure	SET/RE SET Voltage	On/off ratio	Endurance (Cycle)	Bending cycle	Ref.
1	CsPbBr ₃	Al/CsPbBr ₃ /PEDOT: PSS/ITO/PET	-0.6/1.7	10 ²	50	100	1
2	CsBi ₃ I ₁₀	Al/CsPbBr ₃ /ITO substrate	-1.7/0.9	10 ³	150	-	2
3	CsPb _{1-x} Bi _x I ₃	Ag/CsPb _{1-x} Bi _x I ₃ /ITO	-3.6/4	10 ²	500	-	3
4	MA ₃ Bi ₂ I ₉	Au/MA ₃ Bi ₂ I ₉ /ITO	-0.6/1.5	10 ²	300	-	4
5	MAPbI _{3-x} Cl _x	Au/MAPbI _{3-x} Cl _x /FTO	0.9/-0.65	10	100	-	5
6	MAPbI ₃	Au/MAPbI ₃ /ITO/PET	0.7/-0.5	10	400	-	6
7	Cs ₄ PbBr ₆	Au/Cs ₄ PbBr ₆ /PEDOT: PSS/ITO			100		7
8	CsPb ₂ Br ₅	Al/CsPb ₂ Br ₅ /ITO/PET	2.5/-2	10	100	500	This work

References

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